Electronic Acknowledgement Receipt

EFS ID:	1315957
Application Number:	10678359
International Application Number:	
Confirmation Number:	1813
Title of Invention:	Wafer-level transfer of membranes with gas-phase etching and wet etching methods
First Named Inventor/Applicant Name:	Eui-Hyeok Yang
Customer Number:	20985
Filer:	Bing Ai/Susan Sesnovich
Filer Authorized By:	Bing Ai
Attorney Docket Number:	06618-917001
Receipt Date:	15-NOV-2006
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Application Type:	Utility

Payment information:

Submitted with Payment	no

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1		response.PDF	141145	yes	6

	Multipart Description/PDF files in .zip description		
	Document Description	**Start**	**End**
	Amendment - After Non-Final Rejection	1	1
	Claims	2	5
	Applicant Arguments/Remarks Made in an Amendment	6	6
Warnings:			
Information:			
	Total Files Size (in bytes):	141145	

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New Applications Under 35 U.S.C. 111
If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371
If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.